

## Publikationen

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- (2019): Mid-spatial frequency errors in feed direction occurring in ADAPT polishing. In: Proceedings of SPIE 11171 (Sixth European Seminar on Precision Optics Manufacturing, 1117101 [April 9th-10th 2019, Teisnach]), Bellingham, WA, USA. DOI: 10.1117/12.2528114.
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